

# **Notice of References Cited**

Application/Control No.

10/052,549

Applicant(s)/Patent Under  
Reexamination  
EBINA ET AL.

Examiner

Marcos D. Pizarro-Crespo

Art Unit

2814

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## **U.S. PATENT DOCUMENTS**

*	Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
A	US-2002/0168813	11-2002	Ogura	438/200
B	US-4,372,031	02-1983	Tsaur et al.	438/257
C	US-6,091,101	07-2000	Wang, Ling-Sung	257/315
D	US-6,248,633	06-2001	Ogura et al.	438/267
E	US-			
F	US-			
G	US-			
H	US-			
I	US-			
J	US-			
K	US-			
L	US-			
M	US-			

## **FOREIGN PATENT DOCUMENTS**

*	Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
N					
O					
P					
Q					
R					
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T					

## **NON-PATENT DOCUMENTS**

*	Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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V	
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